## 03500.011686.1

## **PATENT APPLICATION**

|                             |  |                  |   | 44 | $\nu$ ( |   |
|-----------------------------|--|------------------|---|----|---------|---|
| In re Application of:       |  | )                | Examiner: V. Perez Ramos Group Art Unit: 1765 |    |         |   |
| YOSHIHIKO FUKUMOTO          |  | ;<br>)<br>;<br>) |   |    |         |   |
| Application No.: 09/429,530 |  |                  |   |    |         |   |
| Filed:                      | October 28, 1999                               | :<br>)           |   |    |         |   |
| For:                        | METHOD FOR FABRICATING<br>SEMICONDUCTOR DEVICE | )                | May 3 2002                                    | <  | 6-0     | 2 |

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Commissioner for Patents Washington, D.C. 20231

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Sir:

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Applicant's undersigned attorney may be reached in our Washington, D.C. office by telephone at (202) 530-1010. All correspondence should continue to be directed to our address given below.

Respectfully submitted,

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